

PATENT Customer No. 22,852 Attorney Docket No. 04329.3238

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re	Application of:	)
	Gaku Minamihaba et al.	) Group Art Unit: 2818
Application No.: 10/771,060		) Examiner: Goodwin, David J.
Filed	: February 4, 2004	) )
For:	POLISHING PAD AND METHOD OF MANUFACTURING SEMICONDUCTOR DEVICES	) Confirmation No.: 2231 ) )
P.O.	missioner for Patents Box 1450 andria, Virginia 22313-1450	
Sir:		

## PETITION FOR EXTENSION OF TIME

Applicant hereby petitions for a one month extension of time to reply to the Office Action mailed January 23, 2007. A fee of \$120.00 is enclosed.

Please grant any additional extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

Dated: May 23, 2007

Selah C. Park Reg. No. 57,127

> 05/24/2007 YPOLITE1 00000068 10771060 01 FC:1251 120.00 OP